Attorney's Docket No.: 07977-182002 / US3413D1



UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yamazaki, et al.

Art Unit: 2823

Serial No.: 09/635,832

Examiner: Fernando Toledo

Filed

: August 9, 2000

Title

: SEMICONDUCTOR DEVICE HAVING SOI STRUCTURE AND

MANUFACTURING METHOD THEREFOR

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Copies of the references listed on the attached form PTO-1449 are enclosed.

This statement is being filed within three months of the filing date of a Request for Continued Examination and before the receipt of an Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: October 9, 2003

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| • | | | Sheet <u>1</u> of <u>1</u> |
|---|--|------------------------------------|----------------------------|
| | Substitute Form PTU-1449 | Attorney's Docket No. 07977-182002 | Application No. 09/635,832 |
| | Information Discharge Statement | Applicant Yamazaki, et al. | |
| | by Applicant (Use several sheets if necessary) | Filing Date August 9, 2000 | Group Art Unit 2823 |
| | (37 CFR §1.98(b)) | | |

| | | | U.S. Pate | ent Documents | | | Filing Date |
|----------------|--------------|--------------------|---------------------|-----------------|-------|----------|----------------|
| Examiner | Desig. | Document Number | Publication Date | Patentee | Class | Subclass | If Appropriate |
| <u>Initial</u> | AA | 5,266,507 | 11/30/1993 | Wu | | | 05/18/1992 |
| | AB | 5,563,440 | 10/08/1996 | Yamazaki et al. | | | 08/22/1994 |
| | | 5,604,137 | 02/18/1997 | Yamazaki et al. | | | 06/02/1995 |
| | AC | 5,095,347 | 03/10/1992 | Kirsch | | | 08/01/1990 |
| | AD | 3,093,347 | 03/10/1332 | | | | |
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| | | n Patent Docu | Publication | Country or | \top | | | |
| Examiner | Desig. | Document Number | Date | Patent Office | Class | Subclass | Yes | No |
| Initial | AL | 61-222254 | 10/02/1986 | JAPAN | | | ABS | |
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| | AM | 05-335482 | 12/17/1993 | | | | | |
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| | AO | | | | | | | |
| | AP | | | | | | <u> </u> | J |

| Other Documents (include Author, Title, Date, and Place of Publication) | | | | |
|---|--------------|----------|--|--|
| Examiner Initial | Desig. ID | Document | | |
| | AQ | | | |
| | AR | | | |
| | AS | | | |
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| Examiner Signature | Date Considered |
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| EXAMINER: Initials citation considered. Draw line through citation if no | ot in conformance and not considered. Include copy of this form with |
| next communication to applicant. | Substitute Disclosure Form (PTO-1449) |

next communication to applicant.